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AMENDMENT UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
GROUP 2873
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Mikhail Abramovich GAN, et al.

Appln. No.: 10/779,859

Confirmation No.: 6217

Filed: February 18, 2004

Docket No: Q79849

Group Art Unit: 2873

Examiner: David N. SPECTOR

<p>APPROVED FOR ENTRY 1/19/2005 DAVID SPECTOR PRIMARY EXAMINER</p>
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For: LENS SYSTEM, AND OBJECTIVE LENS SYSTEM AND OPTICAL PROJECTION
SYSTEM USING THE SAME

AMENDMENT UNDER 37 C.F.R. § 1.116

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated September 13, 2005, please amend the above-identified application as follows on the accompanying pages.

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